

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Yasunori Ito, et al.  
Serial No.: 10/640,850  
Filed: August 13, 2003  
For: METHOD OF PRODUCING  
CERAMIC THERMISTOR  
CHIPS  
Group Art Unit: 1795  
Examiner: H. D. Wilkins III  
Attorney Docket: MURTP083D1

**CERTIFICATE OF EFS-WEB  
TRANSMISSION**

I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on December 14, 2007.

Signed: /Deborah Neill/  
Deborah Neill

**PRELIMINARY AMENDMENT "G"**

MS: RCE  
Commissioner for Patents  
Alexandria, Virginia 22313-1450

Sir:

In response to the Final Office Action dated September 20, 2007 and the Advisory Action dated December 10, 2007 in the above-referenced application, applicant is submitting a Request for Continued Examination (RCE) pursuant to 37 C.F.R. 1,114 simultaneously herewith, together with a fee for said RCE. The instant PRELIMINARY AMENDMENT is being filed as the "submission" related to said RCE in which the application is amended as follows: